



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/217,213

Filed: December 21, 1998

Inventors:

Mark I. Gardner

H. Jim Fulford

Derick J. Wristers

Title: Semiconductor Fabrication
Employing Implantation of
Excess Atoms at the Edges of a
Trench Isolation Structure

Examiner: Mai, Anh D.

Group/Art Unit: 2814

Atty. Dkt. No: 5500-05001

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

Robert C. Kowert

Printed Name

Signature

December 21, 2004

Date

NOTICE OF CHANGE OF ADDRESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants respectfully request the Commissioner to change the correspondence address for the above identified patent application as described below.

Old Address:	Kevin L. Daffer Conley, Rose & Tayon, P.C. P.O. Box 3267 Houston, Texas 77253-3267 (512) 476-1400
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New Address:	Robert C. Kowert Meyertons, Hood, Kivlin, Kowert & Goetzel, P.C. P.O. Box 398 Austin, Texas 78767-0398
Main Phone No.:	(512) 853-8800

Respectfully submitted,

B. Noel Kivlin
Reg. No. 33.929
ATTORNEY FOR APPLICANT(S)

Date: December 21, 2004